

Databases for retrieval of external work products (OPD)

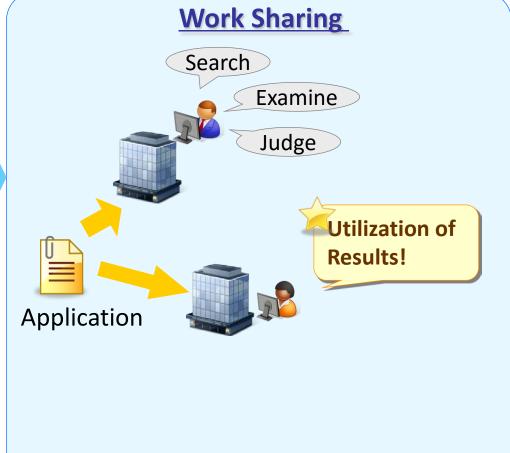
Japan Patent Office March 17th, 2016

1. Work Sharing for Patent Examination



Work Sharing for Patent Examination is to utilize search & examination results (Dossier information) provided by other IP Offices.

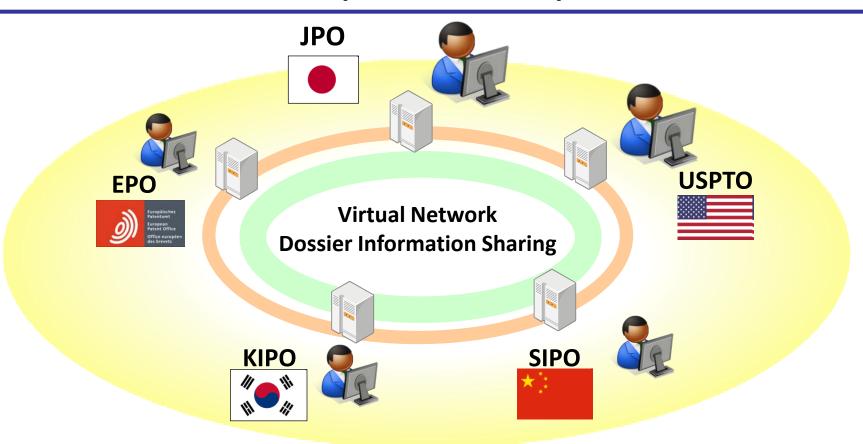




2. One Portal Dossier (OPD)



- Examiners of IP5 Offices can access dossier information of all IP5 Offices at One Stop.
- Dossier Information Sharing is achieved with distributed architecture and common communication protocol "OPD Spec".

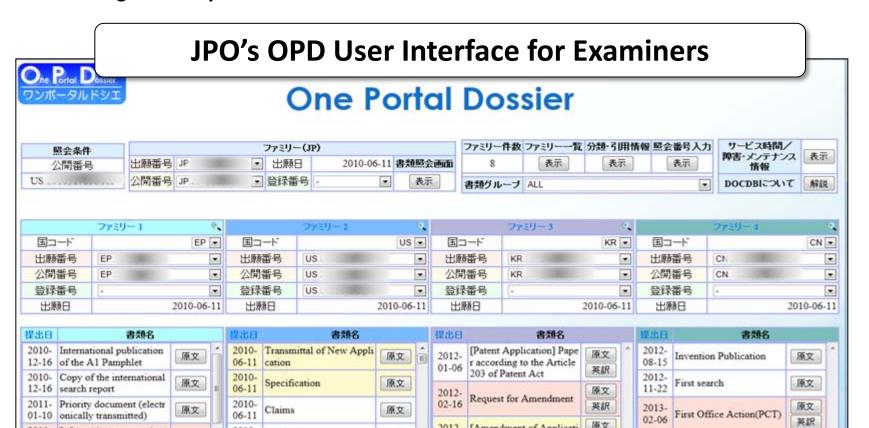


2. One Portal Dossier (OPD) (Contd.)



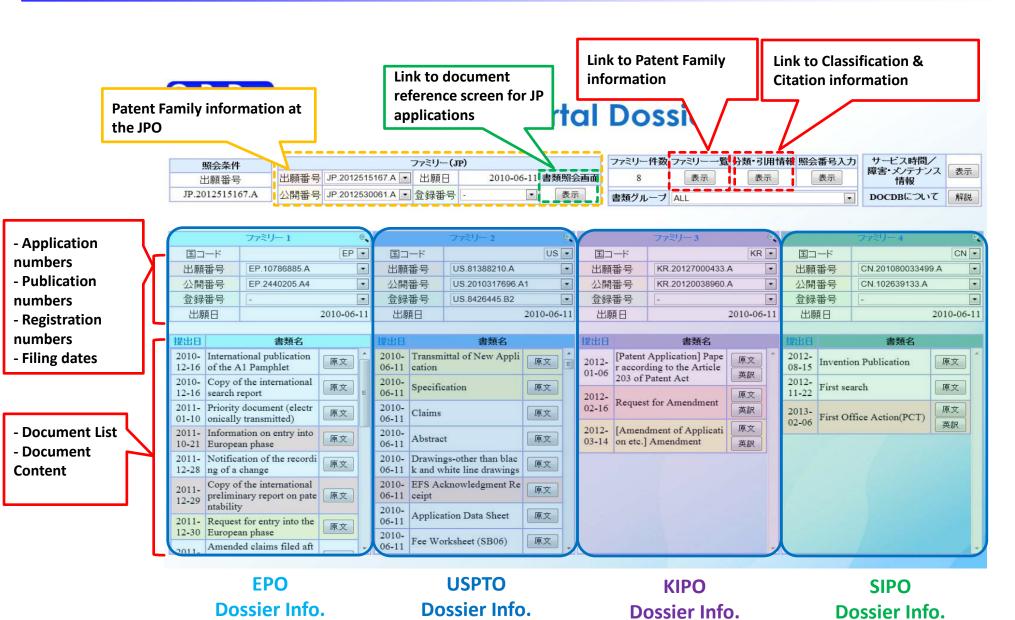
- One Portal Dossier launched in July 2013 among IP5 Offices
 - ✓ JPO's examiners access 52,000 documents* of the other IP5 Offices monthly
 - ✓ Other four Offices' examiners access 37,000 documents* of JPO monthly

*the average monthly access in 2015



2. User Interface of OPD Description of "One Portal Screen," a Main Screen of OPD at the JPO





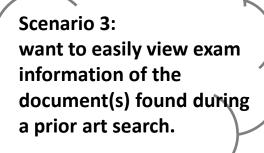
2. User Interface of OPD

Scenarios: Inquiry of the Dossier Information Using OPD



Scenario 1:
want to investigate the status
of corresponding patent
family application(s) subject
to the examination at the
foreign IP Office(s).

Scenario 2:
want to check the exam
result(s) of (a) foreign patent
document(s) cited in a search
report.





Access to search exam information on (a) patent family application(s) of the national application(s)



1. Inquiry using an application number / publication number of the national application(s)



Access to search exam information on the foreign application(s)



2. Inquiry using an application number / publication number of the foreign application(s)



Access from other system



3. Direct jump to OPD from other system

2. User Interface of OPD

Scenario 1: Inquiry by a National Application/Publication Number





2. • User Interface of OPD

Scenario 2: Inquiry by a Foreign Application/Publication Number







Scenario 3: Direct jump to OPD from other system (Access from Cluster Search System)

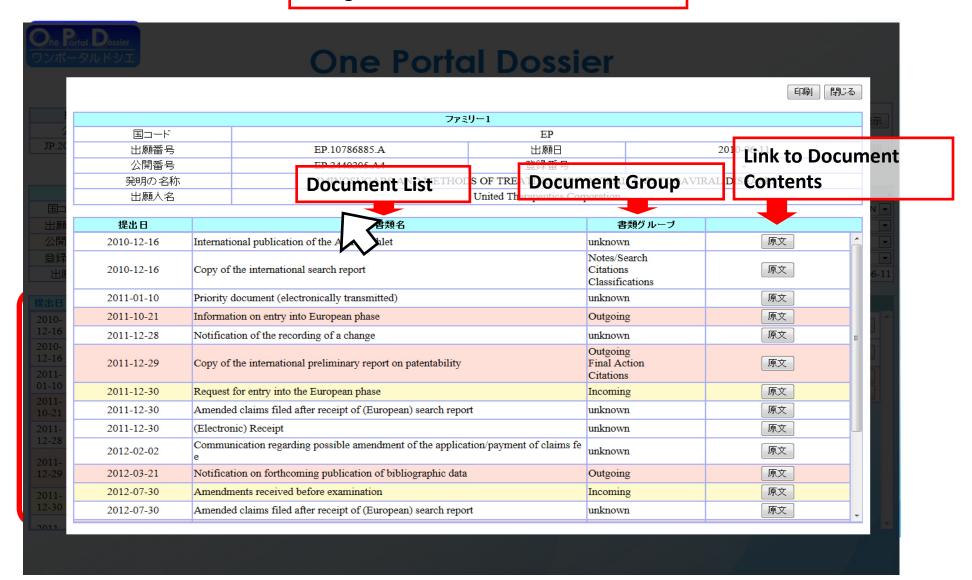






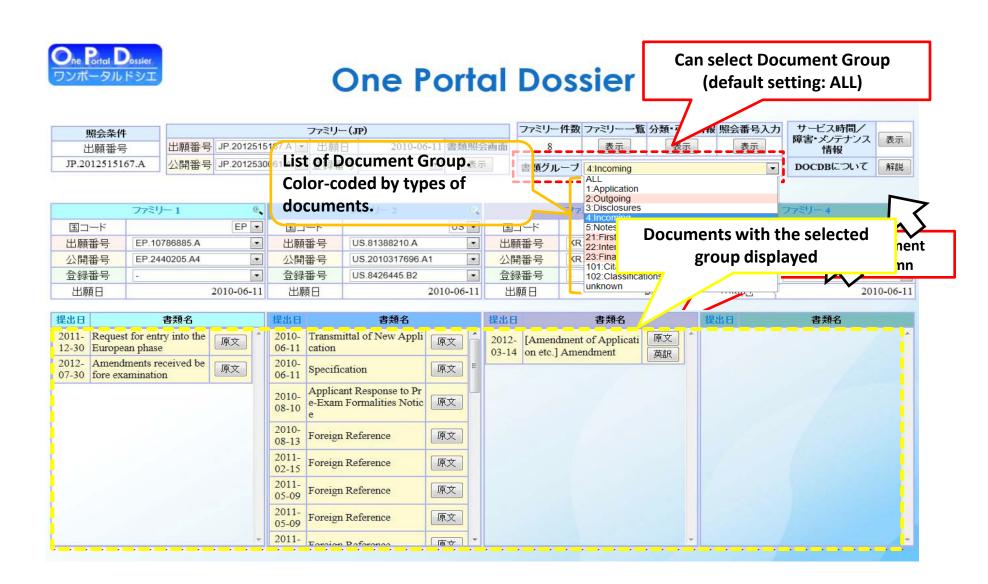


Enlarged View of Document List



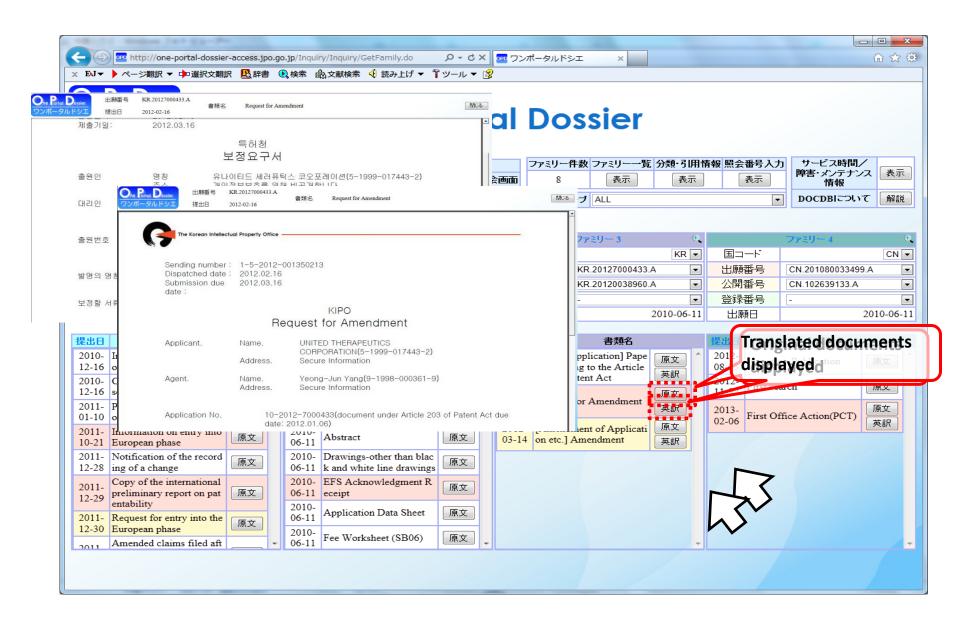
2. User Interface of OPD Selecting Document Group





2. User Interface of OPD Reference to Document Contents



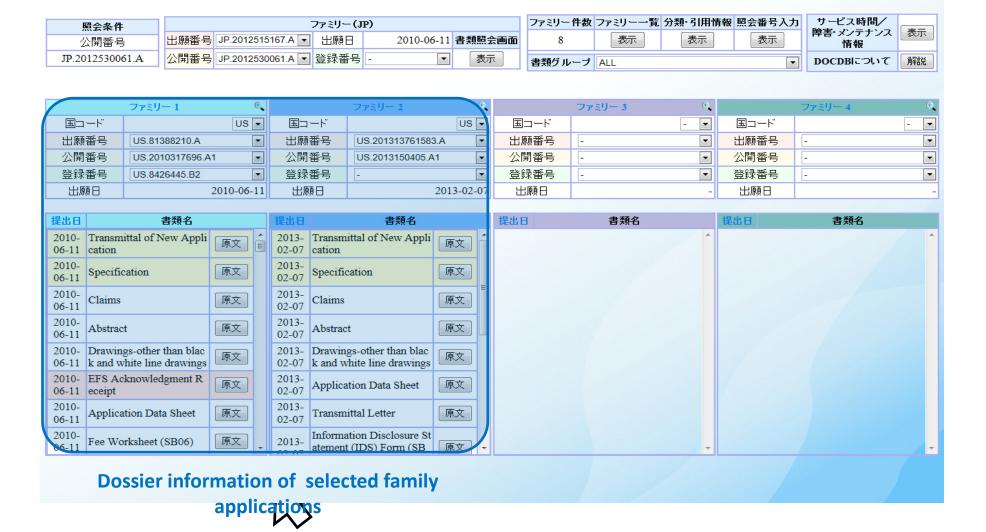


2. User Interface of OPD Reference to a List of Family Applications





One Portal Dossier



2. User Interface of OPD Reference to Classification & Citation Information





Classification&Citation Information

WO.2010027996.A1

WO.2010109330.A2

Classification information. IPC and non-IPC can be displayed.

Link to classification & citation

登録番号

<表示設定>

| 分類一括別に | 分類一括別にる | | 引用一括別にる | |

<出願番号>

■をクリックして公開/登録番号を表示

■ EP.10786885.A
 ■ US.201313761583.A
 ■ US.81388210.A
 ■ KR.20127000433.A
 ■ CN.201080033499.A

Application numbers of family applications. Numbers of related gazettes can be also displayed.

<分類・引用情報>

1

2

XP

Е

出願番号

	EP.1078688	35.A	EP.244020)5. A 1		
■分類情	报					
		IPC			オリジナル	
A61K31/4	45		A6	51K31/445		CPC
A01N43/4	0					
A61P31/1	2					
■引用情	报					
項番	カテゴリ	公開番号	形式	公知日	引用箇所	請求項

公開番号

3	X	WO.2006077427.A2	docdb	-	-	-
項番	カテゴリ	非性	許文献		引用箇所	請求項
1	Y	MEHTA ANAND ET AL: "Immore potent as antivirals, in vit N-n-nonyl DNJ", ANTIVIRAL CHEMOTHERAPY, BLACKWELL SCIENTIFIC F 5, 1 September 2002 (2002-09-01), ISSN: 0956-3202	ino sugars that ar ro, compared with CHEMISTRY & UBL., LONDON	n z, g, GB, vol. 13, n		-

docdb

docdb

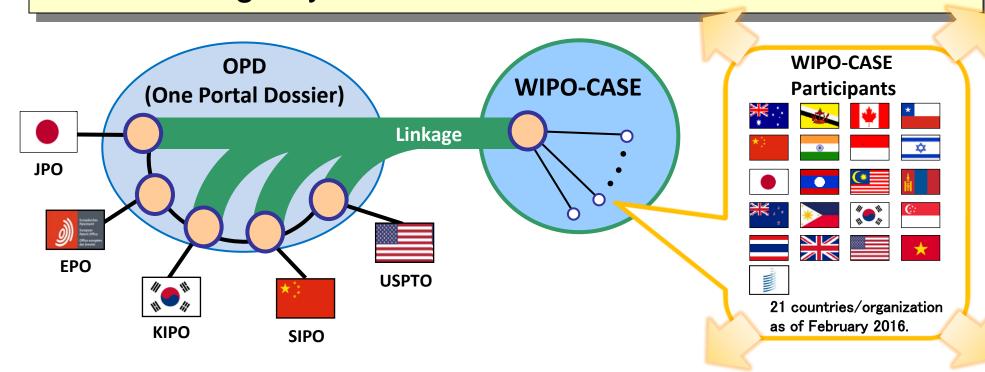
Document information which has been cited.



✓Three major networks for work sharing: OPD, WIPO-CASE and Linkage system between OPD and WIPO-CASE.

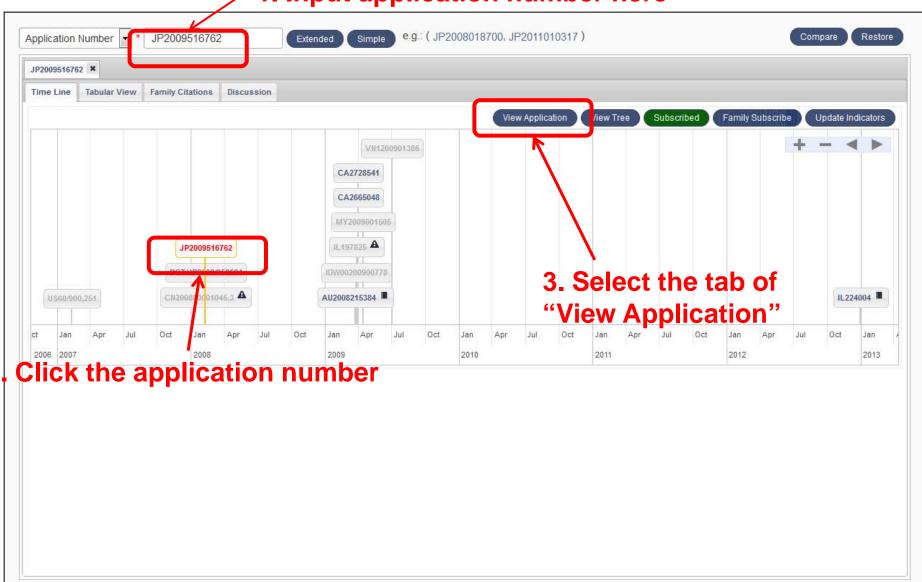


- WIPO-CASE participants can refer to OPD's dossier information via Linkage.
- WIPO CASE system is provided free of charge by the International Bureau of WIPO.

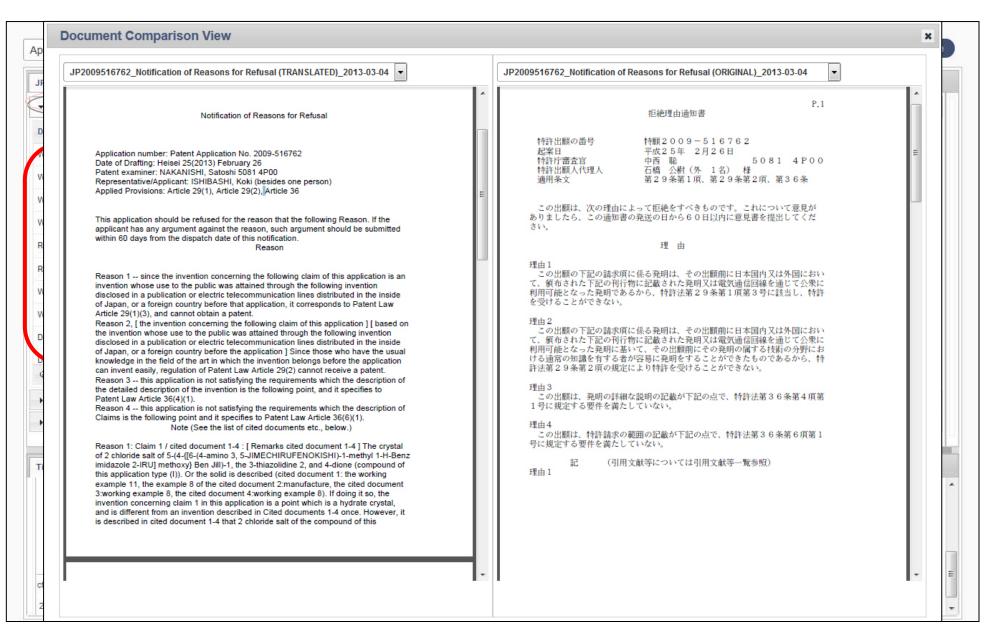




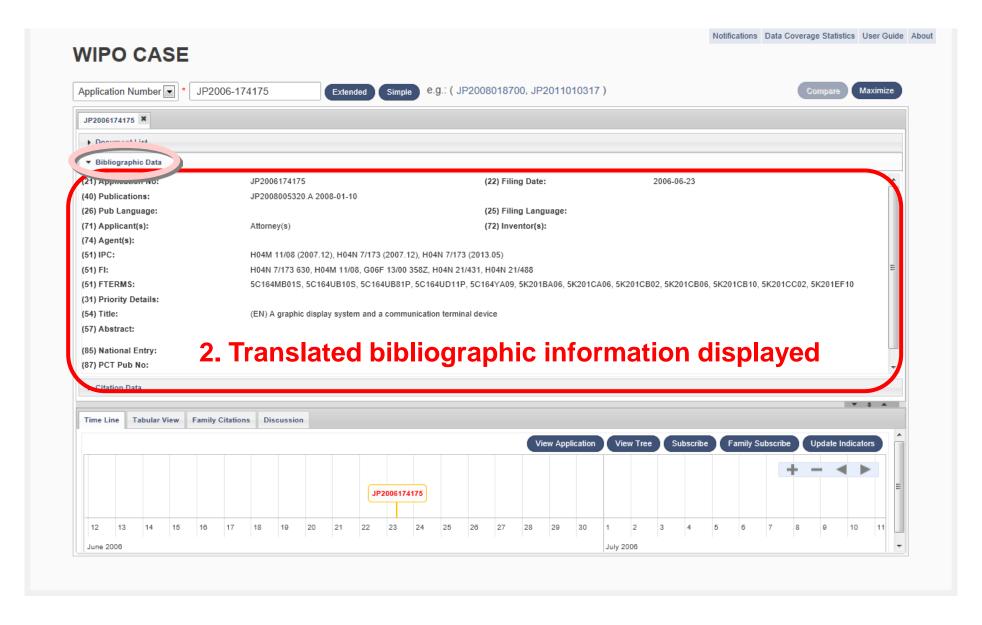








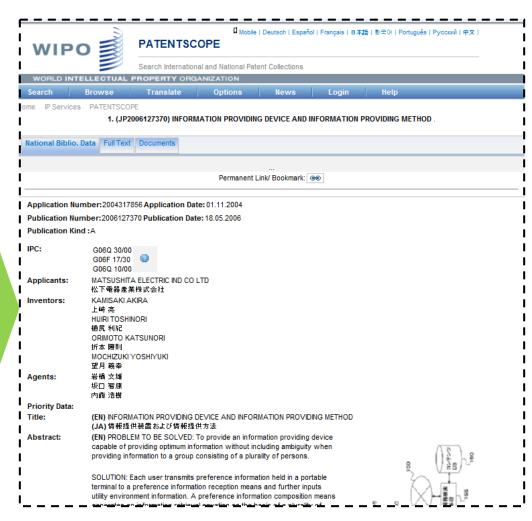






Citation data cited in the dossier information in the form of DOCDB

	lication Number * JP2006-174175 Extended Simple
2772	
10	Document List
•	Bibliographic Data
•	Citation Data
100	Citation
	JP2006127370
100	JP2006053903
E	JP2003234709



You will be able to see the detailed information on the PATENTSCOPE.



Thank you!